



IFW

Docket No.: P2000,0361

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/609,464  
Applicant : Wolfgang Dickenscheid, et al.  
Filed : June 27, 2003  
Art Unit : 2123  
Title : Method for Characterizing and Simulating a Chemical  
Mechanical Polishing Process  
Docket No. : P2000,0361  
Customer No. : 24131

STATUS LETTER

Commissioner for Patents,  
P.O. Box 1450, Alexandria, VA 22313-1450

Sir:

It is respectfully requested that this Status Letter be returned to:

LERNER AND GREENBERG, P.A.  
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Hollywood, FL 33022-2480  
Tel: (954) 925-1100  
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with an indication as to when an action may be expected.

Respectfully submitted,

Alexia J. Vrahimis

Date: January 14, 2005

/av